## AMENDMENTS TO THE CLAIMS

Please enter the following amendments.

- 1. (Currently Amended) A method for treating a backing element comprising a gasket for forming a sealed array assay chamber when joined to a microarray substrate at least one member of a backing element/microarray assembly structure, said method comprising at least one of: (1) depositing a component on said gasket at least one member, (2) extracting a component from said gasket at least one member, to treat said gasket at least one member, to treat said gasket at least one member of a backing element/microarray assembly structure.
- 2. (Currently Amended) The method of Claim 1, wherein said method comprises depositing a component on said <u>gasket</u> at least one member of a backing element/microarray assembly structure and said depositing comprises performing a SiO<sub>2</sub> deposition protocol.
- 3. (Currently Amended) The method of Claim 1, wherein said method comprises extracting a component from said <u>gasket</u> at least one member of a backing element/microarray assembly structure.
- 4. (Currently Amended) The method of Claim 3, wherein said method comprises contacting said <u>gasket at least one member of a backing element/microarray</u> assembly structure with at least one of a liquid phase and a vapor phase.
- 5. (Currently Amended) The method of Claim 3 Claim 4, wherein said component comprises moieties that may adversely affect a microarray assay an array or its reading.
- 6. (Currently Amended) The method of Claim 5, wherein said moieties are removed from said gasket at least from a gasket of said backing element/microarray assembly structure.

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7. (**Original**) The method of Claim 5, wherein said moieties comprise low-melting point monomers or truncated polymers.

- 8. (**Currently Amended**) The method of Claim 7, wherein said low-melting point monomers are **D4-D20 series** linear or cyclic siloxanes.
- 9. (Currently Amended) The method of Claim 4, wherein said <u>extracting</u> extraction comprises contacting said <u>gasket</u> at least one member of a backing element/microarray assembly structure with at least one solvent to extract said component.
- 10. (**Original**) The method of Claim 9, wherein said at least one solvent is an aqueous solvent.
- 11. (Currently Amended) The method of Claim 9 Claim 10, wherein said at least one solvent is an organic solvent.
- 12. (Canceled)
- 13. (Canceled)
- 14. (**Original**) The method of Claim 11, wherein said organic solvent is a non-polar organic solvent.
- 15. (**Currently Amended**) The method of Claim 14, wherein said non-polar organic solvent is chosen from aliphatic hydrocarbons, aromatic hydrocarbons, <u>and</u> ethers <del>and</del> <del>glymes</del>.
- 16. (Currently Amended) The method of Claim 1, wherein said method comprises surface modifying said <u>gasket</u> at least one member of a backing element/microarray assembly structure.

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17. (Currently Amended) The method of Claim 16, wherein said surface modification comprises contacting said <u>gasket</u> at least one member of a backing element/microarray assembly structure with a plasma.

- 18. (**Currently Amended**) The method of Claim 17, wherein said plasma is produced from <u>a gas selected from the group consisting of</u> nitrogen, air, argon, oxygen, nitrous oxide, helium, water vapor, carbon dioxide, methane, and combinations thereof.
- 19.-24. (**Canceled**)
- 25. (**Currently Amended**) The method of Claim 16, wherein said surface modification comprises:
  - (a) introducing soluble particulates to uncured said gasket material,
  - (b) curing said gasket material, and
  - (c) solubalizing said soluble particulates to provide <u>a said</u> textured gasket surface.
- 26. (Currently Amended) The method of Claim 1, wherein said treating treatment comprises oxidizing said gasket at least one surface of said at least one member of a backing element/microarray assembly structure.
- 27. (Currently Amended) The method of Claim 1, wherein said <u>treating</u> treatment comprises increasing the hydrophilicity of said <u>gasket at least one member of a backing element/microarray assembly structure</u>.
- 28. (Currently Amended) The method of Claim 1, wherein said <u>treating</u> treatment provides a seal about <u>said gasket</u> at least elastomeric gasket of said backing element/microarray assembly structure.
- 29. (**Currently Amended**) The method of Claim 1, wherein said <u>treating</u> treatment comprises sequentially contacting said <u>gasket</u> at least one member of a backing

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element/microarray assembly structure with at least two of: plasma, <u>UV with O</u><sub>2</sub> UV/O<sub>2</sub> and a solvent.

30.-39. (Canceled)

- 40. (New) The method of Claim 15, wherein said ether is a glyme.
- 41. (New) A method for treating a backing element comprising a gasket for forming a sealed array assay chamber when joined to a microarray substrate, said method comprising extracting a component from said gasket to treat said gasket.
- 42. (New) The method of Claim 41, wherein said method comprises contacting said gasket with at least one of a liquid phase and a vapor phase.
- 43. (New) The method of Claim 41, wherein said component comprises moieties that may affect said microarray or its reading.
- 44. (New) The method of Claim 43, wherein said moieties are removed from said gasket.
- 45. (**New**) The method of Claim 43, wherein said moieties comprise low-melting point monomers or truncated polymers.
- 46. (New) The method of Claim 45, wherein said low-melting point monomers are linear or cyclic siloxanes.
- 47. (New) The method of Claim 42, wherein said extracting comprises contacting said gasket with at least one solvent to extract said component.
- 48. (New) The method of Claim 47, wherein said at least one solvent is an aqueous solvent.

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49. (New) The method of Claim 47, wherein said at least one solvent is an organic solvent.

- 50. (New) The method of Claim 49, wherein said organic solvent is a non-polar organic solvent.
- 51. (New) The method of Claim 50, wherein said non-polar organic solvent is chosen from aliphatic hydrocarbons, aromatic hydrocarbons, and ethers.
- 52. (New) The method of Claim 51, wherein said ether is a glyme.
- 53. (New) A method for treating a backing element comprising a gasket for forming a sealed array assay chamber when joined to a microarray substrate, said method comprising surface modifying said gasket to treat said gasket.
- 54. (New) The method of Claim 53, wherein said surface modification comprises contacting said gasket with a plasma.
- 55. (**New**) The method of Claim 54, wherein said plasma is produced from a gas selected from the group consisting of nitrogen, air, argon, oxygen, nitrous oxide, helium, water vapor, carbon dioxide, methane, and combinations thereof.
- 56. (New) The method of Claim 53, wherein said surface modification comprises:
  - (d) introducing soluble particulates to said gasket,
  - (e) curing said gasket, and
  - (f) solubalizing said soluble particulates to provide a textured gasket surface.